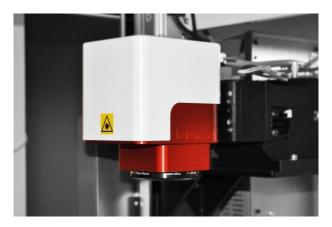
## LS-Scan



## High acceleration laser head

Dedicated to laser **micromachining** and **high accuracy marking**, the LS-Scan is LASEA's unique scan head.

While conventional marking applications require high scanning speeds with accuracies around  $30\mu$ m, micromachining still requires **speed to prevent from heat accumulation**, but the accuracy is a lot more critical, and the drawings often feature a lot more details with constant **needs for accelerations**.

The LS-Scan's technology, based on **flat moving coil motors**, is different from conventional moving magnet technology.

Moving coils being **lighter than magnets** and having a **5 times less current consumption**, the LS-Scan reduces thermal drifts and offer acceleration ramps about **20% smaller** than the best traditional moving magnet scanners.

Thanks to these performances, **more laser power** can be used without degrading the machining accuracy and hence the cycle time can be reduced.

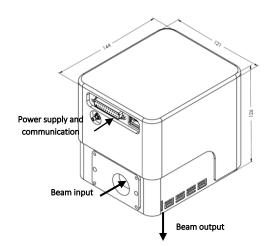
Directly connected to a computer through an ethernet interface, the LS-Scan is driven by our software KYLA<sup>™</sup>, a full **micromachining software** able to communicate with several stages, cameras, and lasers.

Alternatively, the standard XY2-100 protocol can be used with an external control card.

## Key features

- Highest dynamic performance on the market
- Low thermal drifts
- 3D available
- Easy interfacing with KYLA micromachining software
- XY2-100 protocol compatible





Base features	LS-Scan XY 10	LS-Scan XY 15	LS-Scan XY 20	
Scanner aperture	10 mm	15 mm	20 mm	
Tracking error	80 µs	110 µs	160 μs	
Available wavelengths	343 nm - 355 nm - 515/532 + 1.030/1.064 nm - 10.600 nm			
Maximum power	100 W			
Maximum allowed energy (@300fs-1030nm)	400 JU			
Maximum allowed energy (@10ns-532nm)	1 mJ			
Transmission (with F-Theta)	> 90%			
Angular travel	640 mrad			
Maximum scanning speed	70 rad/s			
Static positioning resolution	10 µrad			
Repeatability	+/- 10µrad			
Thermal drift (on 8 hours)	+/- 20µrad			
Size	126 x 121 x 144 mm³			

	Z-axis extension module
Mounting	Before LS-Scan XY
Input aperture	22 mm
Beam diameter modification	x 0,8
Spot size modification	x 1,25
Tracking error	4 ms
Size	109 x 70 x 80 mm <sup>3</sup>

	Options
SiC Mirrors	Improves scanning acceleration due to higher mirror stiffness
C Thata langes	Various F-Theta or telecentric F-Theta lenses available
F-Theta lenses	Supplied with the appropriate adapter ring to prevent from dangerous back reflections
Cutting nozzle	Offers the ability to switch to a gas assisted cutting / drilling process

	Objectives					
Focal length	50 mm	60 mm	80 mm	100 mm	160mm	255mm
Min spot size (M <sup>2</sup> = 1,1, 1.030 nm, LS-Scan 20)	10 µm	12 µm	14µm	16 µm	22 µm	35 µm
Scanning Field	12 x 9 mm²	23 x 13 mm²	28 x 20 mm²	70 x 50 mm²	120 x 70 mm²	200 x 165 mm²
Z field (with Z module option)	0,8 mm	1 mm	2 mm	3 mm	7 mm	20 mm
Working distance	60 mm	66 mm	79 mm	126 mm	176 mm	317 mm

These data can change according to laser beam quality, LS-Scan input aperture, telecentricity, or wavelength

	Connections		
Power supply	12 V – 1 A		
Interfacing	GigE RJ45		

